

# SIMULATION OF THE ELECTRICAL PROPERTIES OF CONDUCTIVE ITO THIN FILMS BY FINITE ELEMENT ANALYSIS

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# Motivation

- Finite element analysis (FEA) can be used to investigate the expected electrical response of materials and devices and compared to experimental results where possible
- Previous work was done on insulating films deposited on conducting substrates (Kumar and Gerhardt, *COMSOL Proc. 2009* and *Meas.Sci.and Tech.*, 2012)
- Effect of film thickness, electrode size, substrate conductivity and film conductivity have also been done (Jin, Kumar and Gerhardt, *COMSOL Proc. 2015*)
- Why study ITO?
  - ITO is the primary transparent conducting material used in the majority of optoelectronic applications
  - Properties of films deposited via sputtering are different from solution processed films
  - Solution processed films can be used to direct write circuit patterns in one step via inkjet printing

# Model Set Up and Equations

- Used AC/DC module and set

$$-\nabla \cdot \left( \left( \sigma + \varepsilon_r \varepsilon_0 \frac{\partial}{\partial t} \right) \nabla V \right) = 0$$

where  $\sigma$  is the electrical conductivity of the material,  $\varepsilon_r$  is the relative permittivity of the material and  $\varepsilon_0$  is the vacuum permittivity ( $8.854 \times 10^{-12}$  F/m)

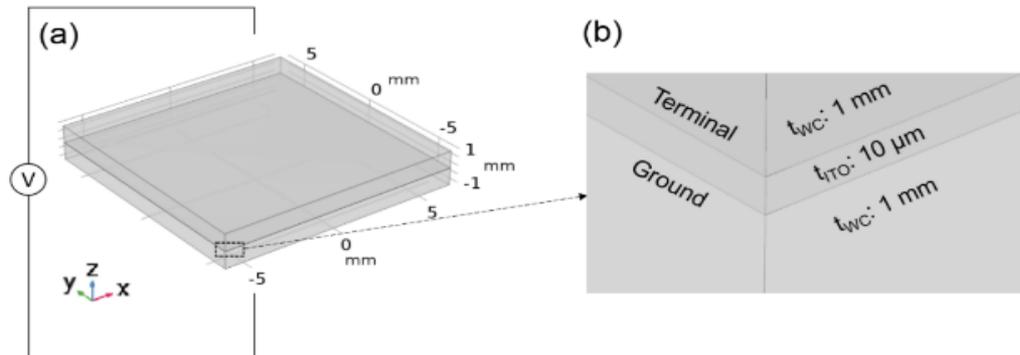
- Materials properties used in the simulation:
  - Air (1.0059,  $3 \times 10^{-15}$  S/m)
  - Quartz glass (4.2,  $1 \times 10^{-12}$  S/m)
  - ITO (4\*, 1180 S/m)
  - Tungsten Carbide (1\*,  $5 \times 10^6$  S/m)

# Modeling Procedure

- Choosing the right 3D model and ac/dc electric currents interface in the COMSOL model wizard
- Drawing films model with or without environment;
- Building the appropriate mesh
- Defining the electrical parameters for each material and boundary
- Computing the model by the right solver in the frequency domain study
- Post-processing the data into other electrical properties

# Parallel plate configuration

- Used 2-terminal configurations in 2D and 3D:



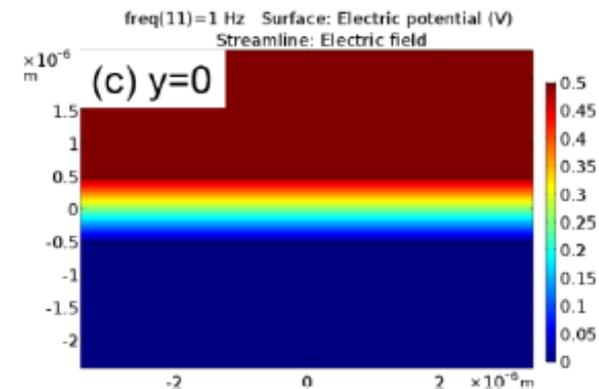
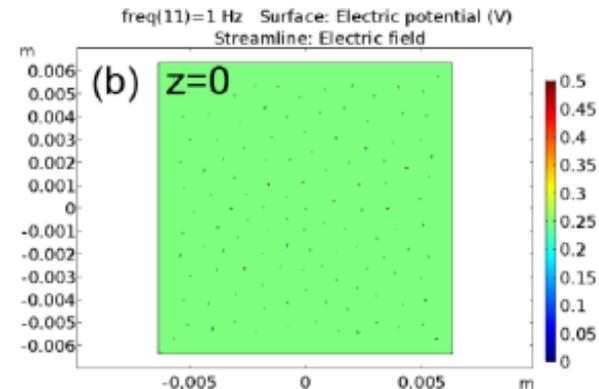
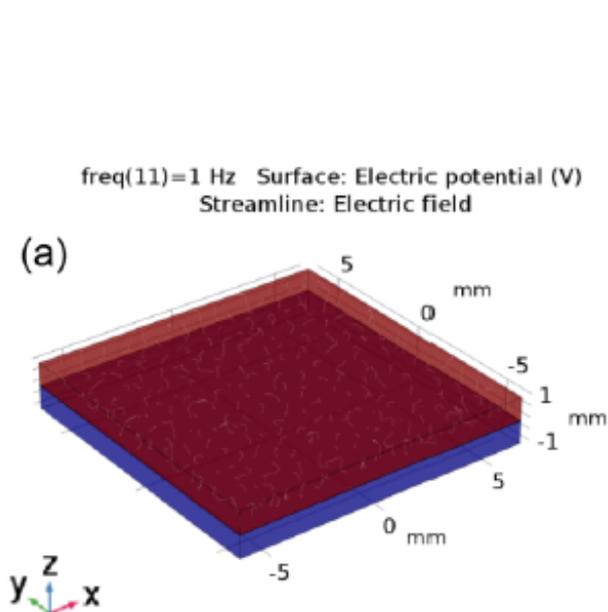
-Top and bottom electrode are

12.7 mm × 12.7 mm × 1 mm thick

-Film is also

12.7 mm × 12.7 mm but the thickness is 10 μm

# Parallel plate results

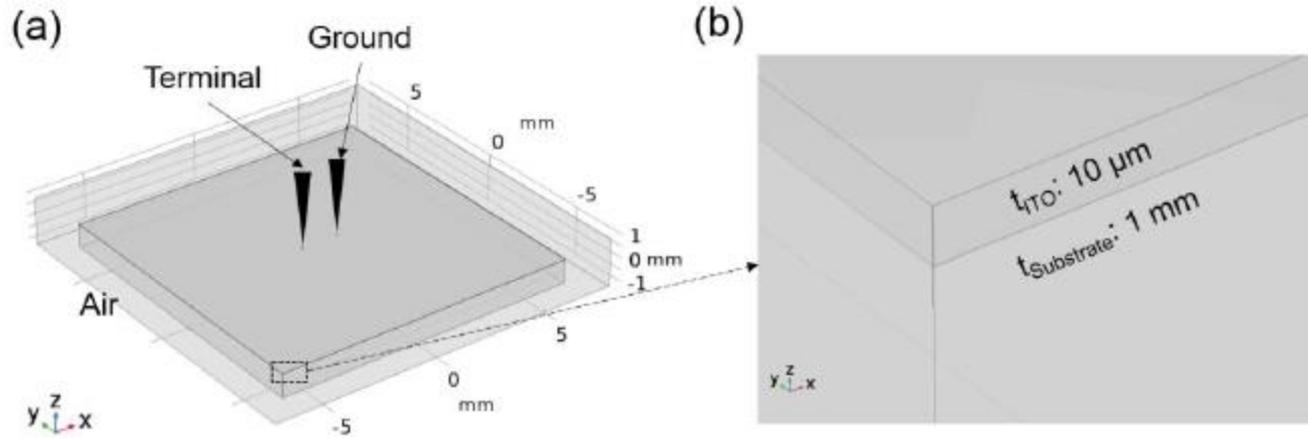


$$R = \frac{\rho L}{A} = \frac{t}{\sigma a^2} = 5.254 \times 10^{-5} \Omega$$

$$C = \frac{\epsilon_r \epsilon_0 A}{d} = \frac{\epsilon_r \epsilon_0 a^2}{t} = 5.712 \times 10^{-10} F$$

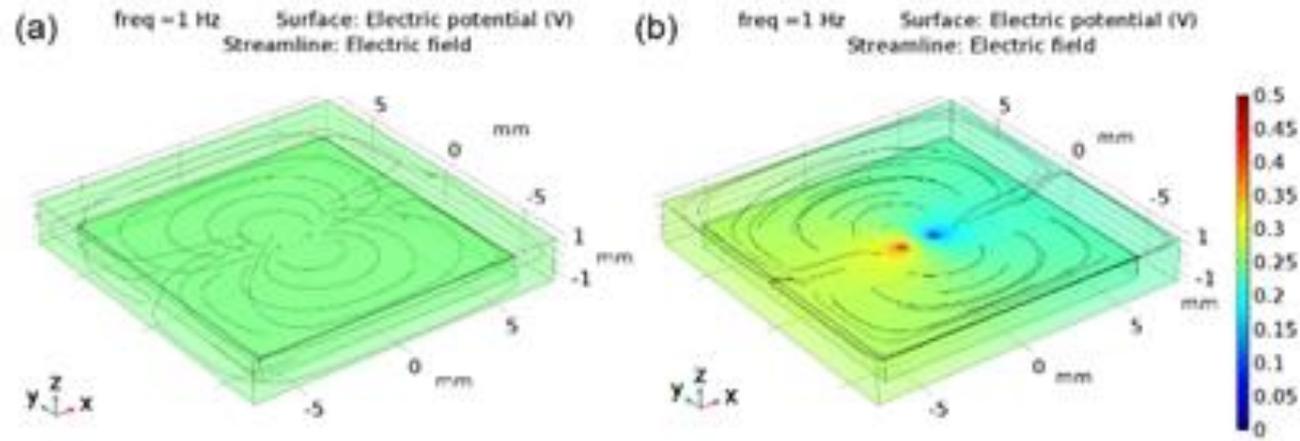
- Simulation results agree with theoretical expectations
- Not possible to measure

# In-plane configuration



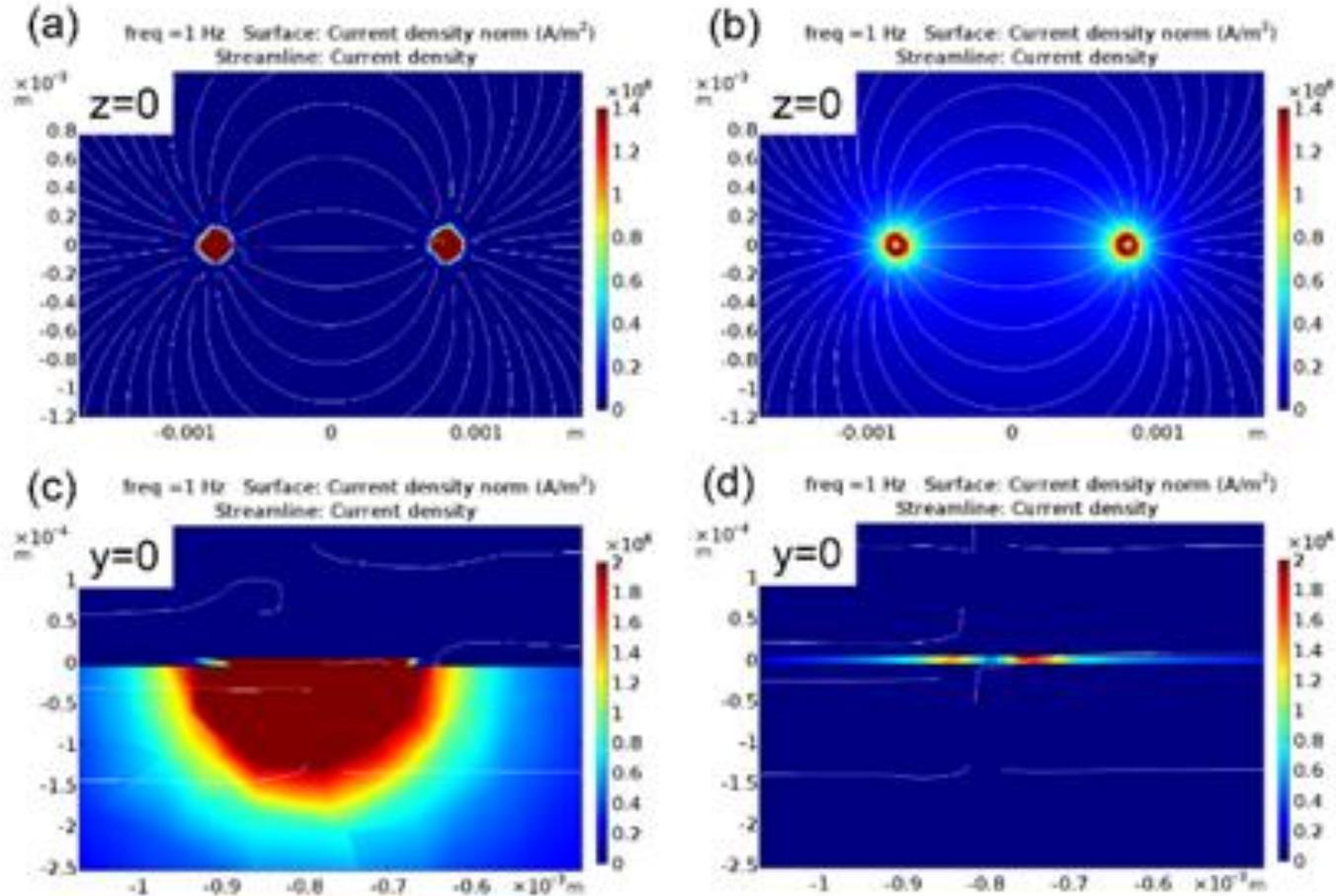
- (a) 3D model geometry for in-plane measurement configuration
- (b) Magnified figure of ITO film on substrate with dimensions
  - $12.7 \text{ mm} \times 12.7 \text{ mm} \times 10 \mu\text{m}$  ITO film
  - $12.7 \text{ mm} \times 12.7 \text{ mm} \times 1 \text{ mm}$  substrate,
  - $D = 80 \mu\text{m}$  circular electrodes with a center spacing of  $1.5875 \text{ mm}$

# Simulated 3D Potential maps on conducting and insulating substrates



- (a) ITO film on conducting substrate
- (b) ITO film on insulating substrate

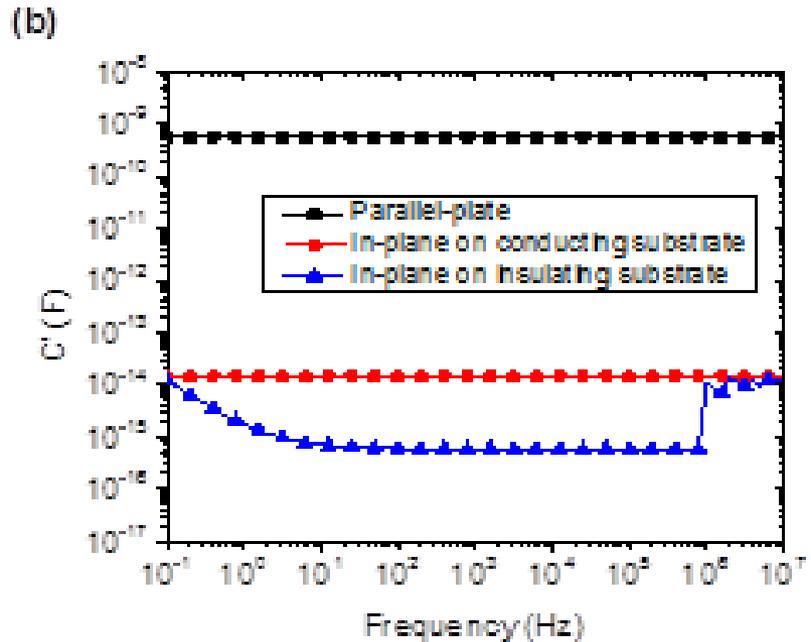
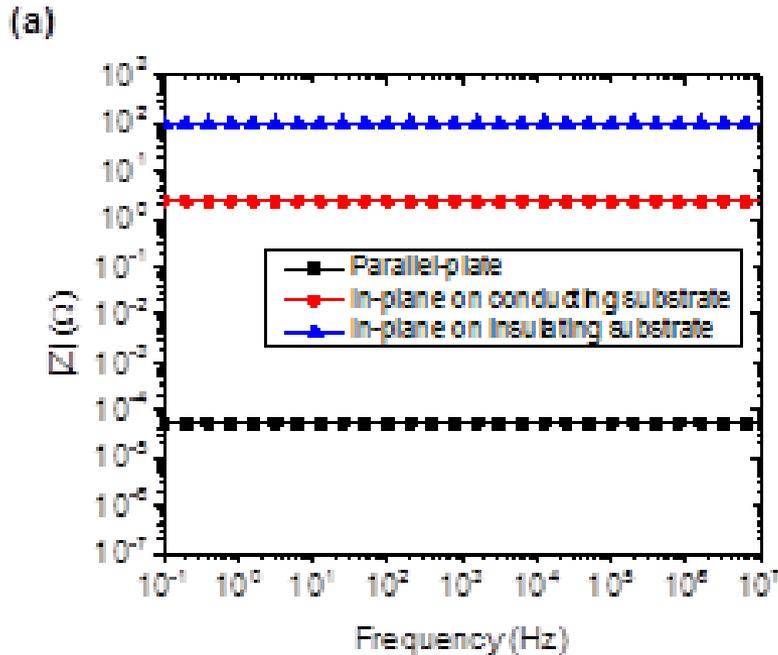
# Current density maps on conducting and insulating substrates



Conducting substrate

Insulating substrate

# Comparison of results with different configurations

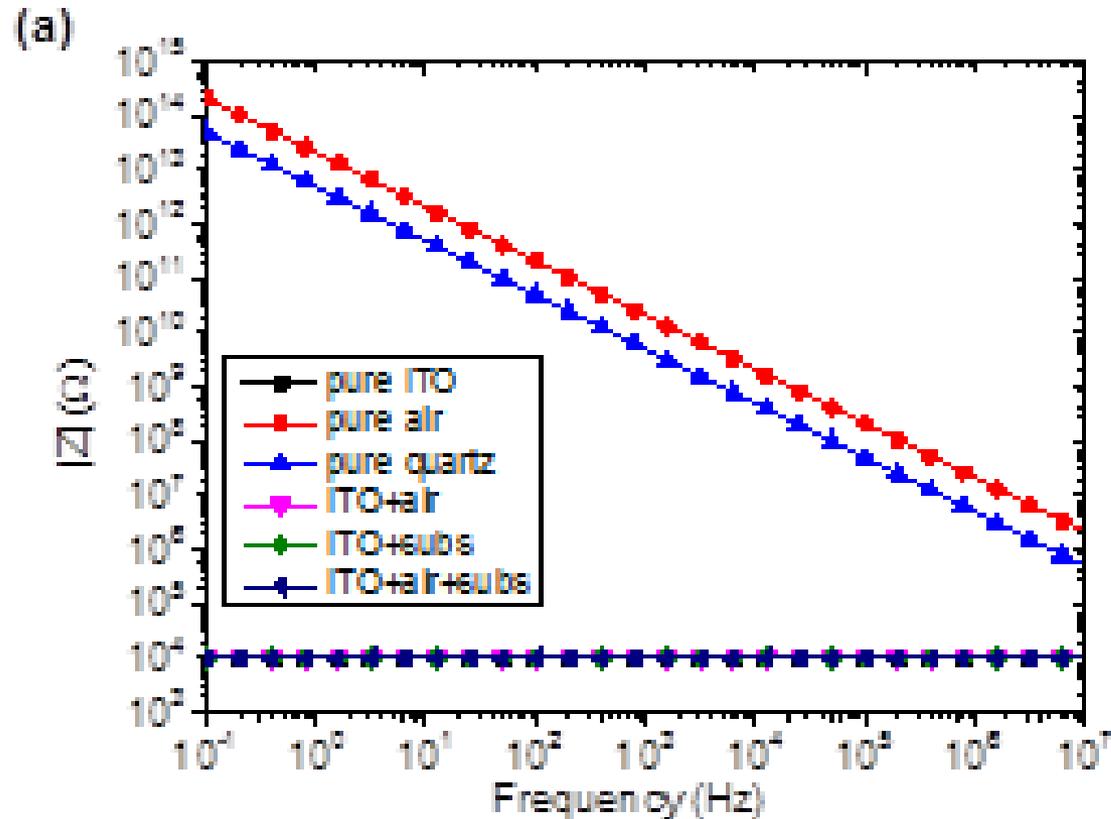


$$Z^* = \frac{1}{Y^*} = Z' + jZ''$$

$$C^* = C' + jC'' = \frac{Y''}{\omega} + j \frac{Y'}{\omega}$$

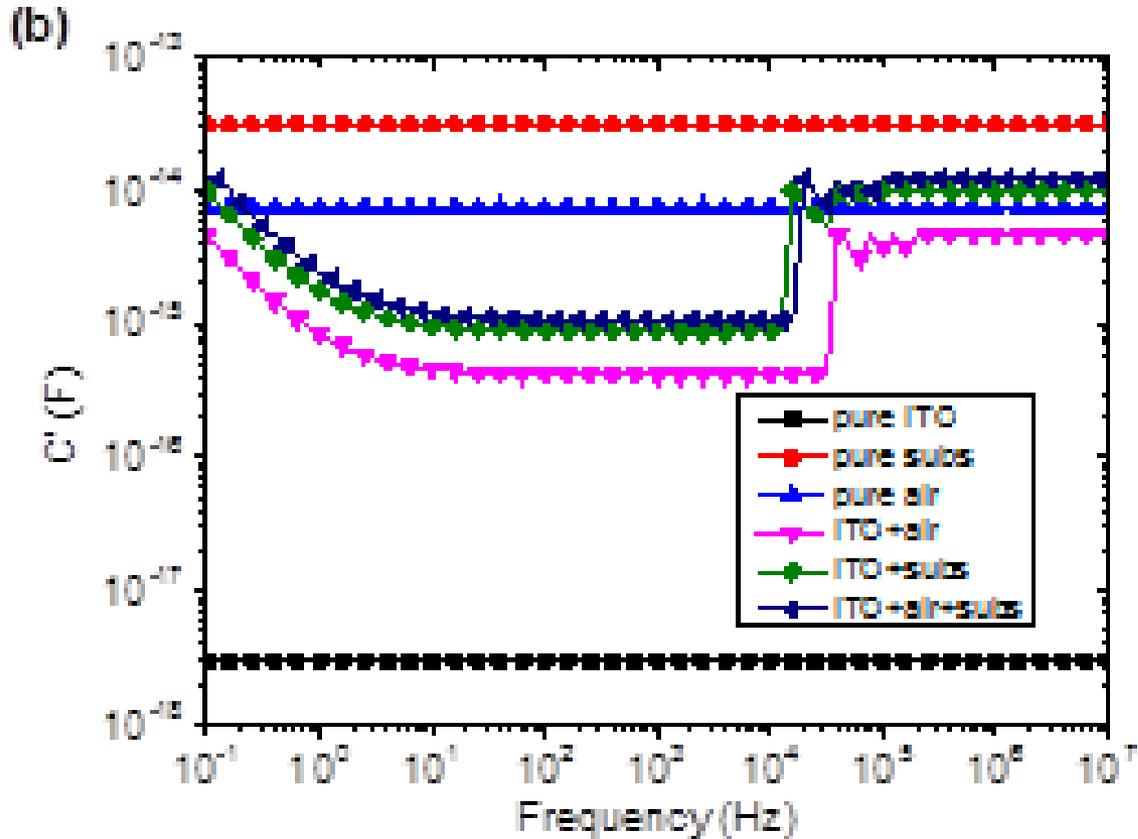
The measurement configuration has a large effect on the resultant properties !! Simulations shown for 10  $\mu\text{m}$  films

# Impedance of different combinations



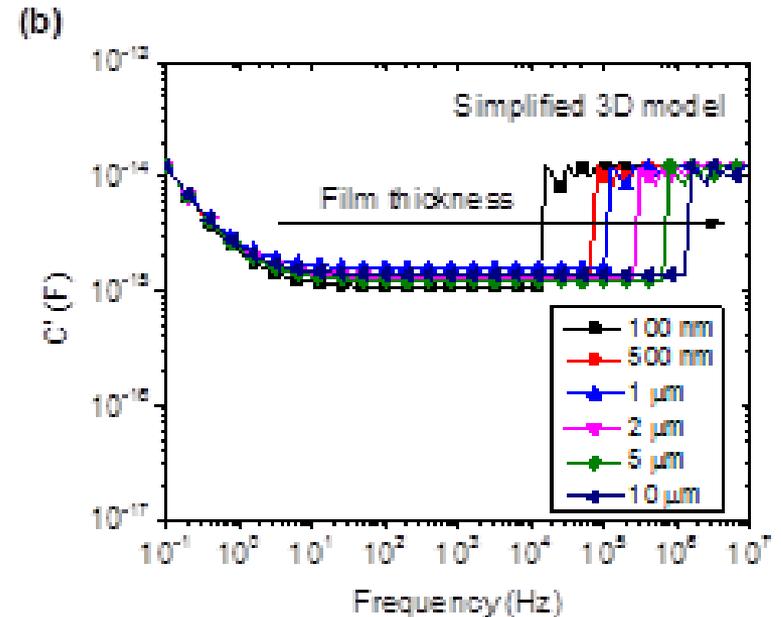
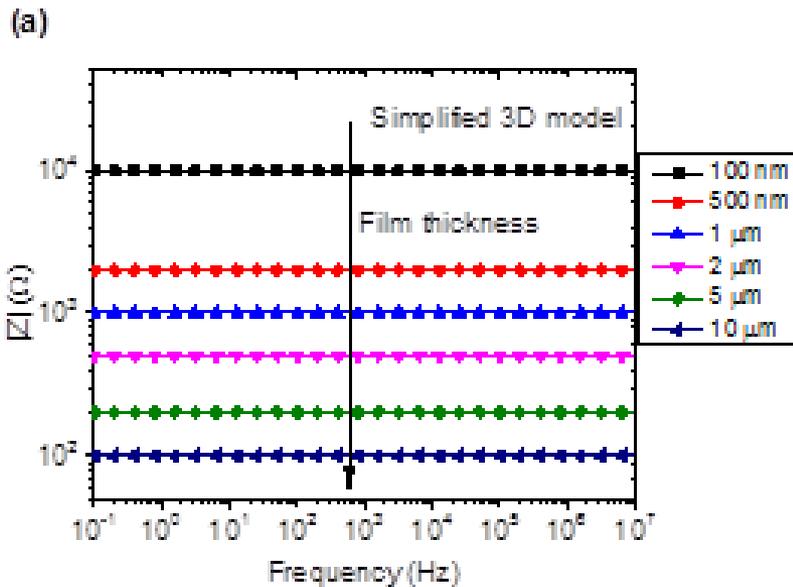
Substrate and surrounding air environment have an insignificant effect on the impedance response of the 100nm ITO films because  $Z''$  is very small and therefore  $|Z^*| \sim Z'$

# Capacitance of different combinations



In-plane capacitance measurement of 100nm ITO film on insulating substrates are dominated by the open circuit capacitance (substrate and air).

# Effect of film thickness on in-plane measurements



- Impedance values decrease with increasing film thickness and remain frequency independent
- Capacitance values as a function of thickness are approximately the same below a certain frequency above which the open circuit capacitance dominates

# Conclusions

- COMSOL Multiphysics was used to simulate the properties of conducting ITO thin films as a function of
  - Measurement configuration
  - Surrounding environment
  - Film thickness
  - Substrate type (conducting or insulating)
- Results indicate that capacitance response is much more sensitive than impedance to the surrounding environment
- Simulations provided insight for situations where it is currently not possible to obtain experimental data

# Acknowledgements

- National Science Foundation under DMR-1207323
- Arnold Magnetics and RF Genesis Inc
- Prof. Gerhardt would like to acknowledge the Goizueta Foundation for travel support